



Image 1765  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date February 25, 2004

In re the Application of

Takao ABE et al.

Group Art Unit: 1765

Application No.: 09/743,982

Examiner: M. Anderson

Filed: January 18, 2001

Docket No.: 108360

For: SILICON SINGLE CRYSTAL AND WAFER DOPED WITH GALLIUM AND METHOD FOR PRODUCING THEM

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired January 27, 2004, an extension of time for a period of 1 month is hereby requested. Attached hereto is our Check No. 151469 in the amount of \$110.00 in payment for:

☒ Extension fee for response within first month pursuant to §1.136(a) (\$110.00)  
☐ Extension fee for response within second month pursuant to §1.136(a) (\$420.00)  
☐ Extension fee for response within third month pursuant to §1.136(a) (\$950.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted

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WPB:JMS/jcp

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DEPOSIT ACCOUNT USE  
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